

SLPC2026 Session Chairs List

Session number & title	Session chair		Affiliation
Opening Remark	塚本 雅裕	Masahiro Tsukamoto	JWRI, The University of Osaka, Japan
1. Direct Energy Deposition	溝尻 瑞枝	Mizue Mizoshiri	Tohoku University, Japan
	酒井 俊明	Toshiaki Sakai	FURUKAWA ELECTRIC CO., LTD., Japan
2. Additive Manufacturing/Selective Laser Melting	山下 順広	Yorihiro Yamashita	University of Fukui, Japan
	佐藤 雄二	Yuji Sato	The University of Osaka, Japan
3. Surface modification 1	竹中 啓輔	Keisuke Takenaka	JWRI, The University of Osaka, Japan
	甲藤 正人	Masahito Katto	University of Miyazaki, Japan
4. Plenary Session	塚本 雅裕	Masahiro Tsukamoto	JWRI, The University of Osaka, Japan
5. Transparent Materails	宮地 悟代	Godai Miyaji	Tokyo University of Agriculture and Technology, Japan
	岡本 泰寛	Yasuhiro Okamoto	Hiroshima University, Japan
6. Beam Shaping	竹中 啓輔	Keisuke Takenaka	JWRI, The University of Osaka
	津山 美穂	Miho Tsuyama	Kindai University, Japan
7. Surface Modification 2	橋田 昌樹	Masaki Hashida	Tokai University/Kyoto University, Japan
		Beat Neuenschwander	Bern University of Applied Sciences, Institute for Applied Laser, Photonics and Surface Technologies ALPS
8. Laser Manufacturing	奈良崎 愛子	Aiko Narazaki	National Institute of Advanced Industrial Science and Technology, Japan
		Timotius Pasang	Western Michigan University, USA
9. Femtosecond Laser Processing	伊藤 祐介	Yusuke Ito	The University of Tokyo, Japan
	長谷川 智士	Satoshi Hasegawa	Utsunomiya University, Japan
10. Short pulse & UV laser processing	甲藤 正人	Masahito Katto	University of Miyazaki, Japan
	塚本 雅裕	Masahiro Tsukamoto	JWRI, The University of Osaka, Japan
Award Ceremony and Closing Remarks of SLPC	塚本 雅裕	Masahiro Tsukamoto	JWRI, The University of Osaka, Japan

(敬称略)